| Electronic Acknowledgement Receipt   |   |  |
|--------------------------------------|---|--|
| EFS ID:                              | 4398254   |  |
| Application Number:                  | 10817611  |  |
| International Application Number:    |   |  |
| Confirmation Number:                 | 2449  |  |
| Title of Invention:                  | Method and system for control of processing conditions in plasma processing systems |  |
| First Named Inventor/Applicant Name: | Sheng Sun   |  |
| Customer Number:                     | 57385   |  |
| Filer:                               | Matthew Temple Sarles/Cindy Bennett   |  |
| Filer Authorized By:                 | Matthew Temple Sarles   |  |
| Attorney Docket Number:              | A7188/T47800  |  |
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| Time Stamp:                          | 16:17:42  |  |
| Application Type:                    | Utility under 35 USC 111(a)   |  |

# **Payment information:**

| Submitted with Payment | no |
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# File Listing:

| Document<br>Number | Document Description | File Name             | File Size(Bytes)/<br>Message Digest          | Multi<br>Part /.zip | Pages<br>(if appl.) |
|--------------------|----------------------|-----------------------|--|---------------------|---------------------|
| 1                  |                      | AMAT_478US_Amend2.pdf | 371559                                       | yes                 | 11                  |
| '                  |                      |                       | 834980bd2fbe21c911654fcd954b16f9b5c3<br>2384 | 1                   |                     |

|           | Multipart Description/PDF files in .zip description   |       |     |
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|           | Document Description                                  | Start | End |
|           | Amendment/Req. Reconsideration-After Non-Final Reject | 1     | 1   |
|           | Claims  | 2     | 7   |
|           | Applicant Arguments/Remarks Made in an Amendment      | 8     | 11  |
| Warnings: |   |       |     |

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## New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

### National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

### New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.